

Notice of References Cited	Application/Control No. 10/072,639	Applicant(s)/Patent Under Reexamination YU ET AL.	
	Examiner Mike Stahl	Art Unit 2874	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0035216	02-2003	Hatano et al.	359/578
	B	US-2003/0021525	01-2003	Turpin et al.	385/24
	C	US-6,292,298	09-2001	Glance	359/583
	D	US-6,252,716	06-2001	Paiam	359/618
	E	US-5,071,225	12-1991	Inoue	359/634
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	C. K. Madsen et al., A tunable dispersion compensating MEMS all-pass filter. IEEE Photonics Technology Letters, vol. 12 no. 6, pp. 651-653. June 2000.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.